

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Number 7,023,059
Issued 4/4/2006
Name of Patentee Darin A. Chan
Title of Invention TRENCHES TO REDUCE LATERAL SILICIDE GROWTH IN INTEGRATED CIRCUIT TECHNOLOGY

ATTN: Certificate of Correction Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT

Please issue a Certificate of Correction for the following mistakes in the above-referenced patent

☒ FOR PTO MISTAKE (37 C.F.R. § 1.322(a))

The exact page and line number where the errors are shown correctly in the application file are:

1. In the specification, page 7, line 14
2. In the specification, page 7, line 17

The exact column and line number where the error occurs in the Patent are:

1. Column 5, line 28, delete "suicides" and insert therefor --silicides--
2. Column 5, line 31, delete "suicides" and insert therefor --silicides--

☒ Attached hereto, in duplicate, is Form PTO-1050, with at least one copy being suitable for printing.

☒ Please send the Certificate to:

Name Mikio Ishimaru
Address The Law Offices of Mikio Ishimaru
333 W. El Camino Real, Suite #330
Sunnyvale, CA 94087

☐ Charge Deposit Account 50-0374 the sum of \$0.00, as required by 37 CFR 1.20(a), and the fee for ____ additional copies of the Certificate of Correction. A duplicate of this request is attached.

CERTIFICATE OF MAILING/TRANSMISSION (37 C.F.R.1.8a)

I hereby certify that this correspondence is on the date shown below being:

☒ Submitted to the United States Patent and Trademark Office via the Electronic Filing System.

Date: 4/14/06

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- ☒ Please charge any shortage in fees due in connection with the filing of this paper to Deposit Account No. 50-0374 and credit any excess fees to such deposit account.

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Date: April 14, 2006